Notice of References Cited Application/Control No. | Applicant(s)/Patent Under Reexamination | BARGE ET AL. | Examiner | Art Unit | Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-6,531,416	03-2003	Kobayashi et al.	438/795
	В	US-			
	С	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	н	US-			
	1	US-			
	J	US-			
	к	US-			
	L	US-			
	м	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification	
	N						
	0						
	Р						
	Q						
	R						
	s						
	Т						

NON-PATENT DOCUMENTS

*	Ĭ	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)					
	U	Peter Van Zant; Microchip fabrication : a practical guide to semiconductor processing; 4th ed.; 2000; McGrawHill, New York, pp.63-64					
	v						
	w						
	х						

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.